

Application No. 10/005,188

In the Abstract

Please substitute the following amended Abstract for the Abstract as currently pending  
(deleted matter is shown by strikethrough or double brackets and added matter is shown by underlining):

A front opening wafer container has a container portion with a transparent shell and a door to close the open front. The container portion has a machine interface on the bottom of the shell, such as a kinematic coupling, and a receptacle at the top of the shell to receive an accessories accessory, in particular a robotic lifting flange or an adaptor plate. The adaptor plate will ideally have [[a]] cooperating machine interface portions to allow stacking of the wafer carriers. The receptacle has, in preferred embodiments, sliding support guides with undercut portions for retention of the robotic lifting flange or the adaptor plate . The accessory will ideally have a detent positioned on the aceessories accessory to releaseably lock said accessory in place on the container portion.